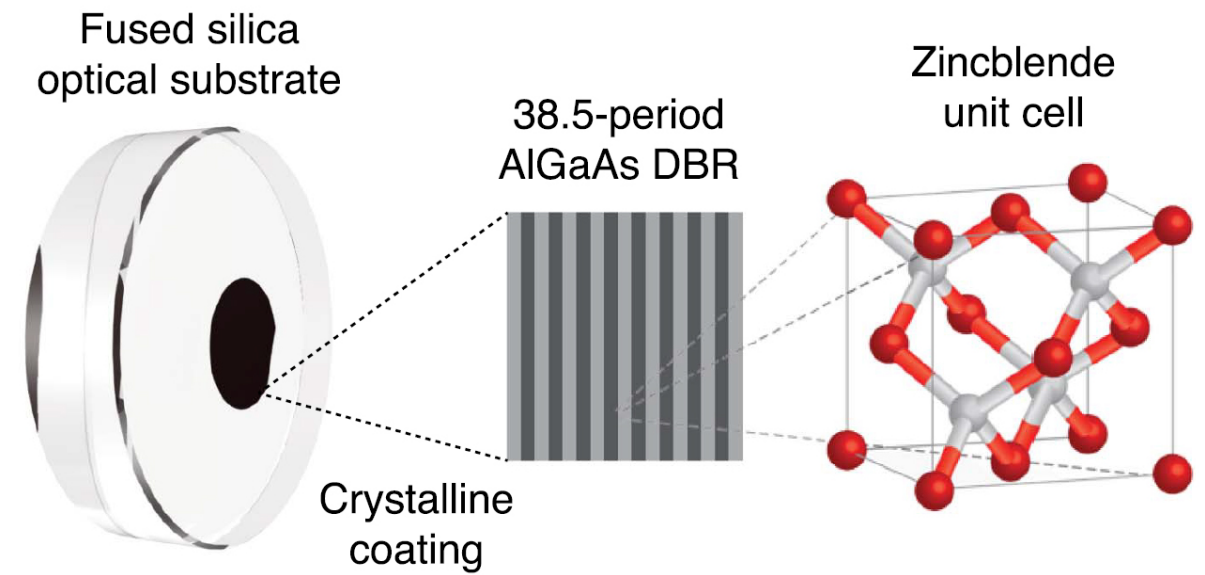


Post-O5 LIGO with Crystalline Coatings

Crystalline GaAs/AlGaAs Coatings • Overview

- The crystal is grown via Molecular Beam Epitaxy (MBE) on a single-crystal GaAs wafer.
- Alternating the Al alloy composition forms a Bragg reflector from layers of $\text{Al}_{0.92}\text{Ga}_{0.08}\text{As}$ ($n = 2.89$) and GaAs ($n = 3.30$)
- Wafer is etched away. Coating is transferred and bonded to substrate.
- Material is bandgap limited to $\lambda > 870 \text{ nm}$
- Bragg reflectors can be made for $\lambda \approx 0.9 - 12 \text{ }\mu\text{m}$. Specific mirrors produced at 1, 1.5, 2, 3.3, 3.8, 4, 4.5 μm



Crystalline GaAs/AlGaAs Coatings • Optical Properties

- Scatter now typically < 5 ppm
 - $\approx 3\text{-}4$ ppm [Gleckl, Fullerton]
 - $\approx 6\text{-}9$ ppm [Marchio]
- Absorption typically < 1 ppm
 - < 1 ppm [Marchio, et al.]
 - $\approx 0.6\text{-}0.7$ ppm at 1064 nm [Cole, 2016]
- Uniformity
 - < 2 nm/5 cm [Koch 2019]
- Laser Damage Threshold
 - > 64 MW/cm² [Koch 2019]
- Finesse: $\approx 500,000$ at 1397 nm
 - $\approx 500,000$ at 1397 nm [Thorlabs]
 - $> 600,000$ at 1550 nm



Amy Gleckl, *et al.*, <https://dcc.ligo.org/LIGO-G2000376>

Marchiò, M. *et al.* Optical performance of large-area crystalline coatings. *Optics Express* **26**, 6114 (2018).

Garrett D. Cole, *et al.*, "High-performance near- and mid-infrared crystalline coatings," *Optica* **3**, 647-656 (2016)

Koch, P. *et al.* Thickness uniformity measurements and damage threshold tests of large-area GaAs/AlGaAs crystalline coatings for precision interferometry. *Opt Express* **27**, 36731 (2019).

Crystalline GaAs/AlGaAs Coatings • Mechanical Properties

Elasticity Matrix (Cubic Crystal — Voigt Notation)

$$\begin{bmatrix} C_{11} & C_{12} & C_{12} & 0 & 0 & 0 \\ C_{12} & C_{11} & C_{12} & 0 & 0 & 0 \\ C_{12} & C_{12} & C_{11} & 0 & 0 & 0 \\ 0 & 0 & 0 & C_{44} & 0 & 0 \\ 0 & 0 & 0 & 0 & C_{44} & 0 \\ 0 & 0 & 0 & 0 & 0 & C_{44} \end{bmatrix}$$

Real Elastic Constants

$$C_{11} = 118 \text{ GPa}$$

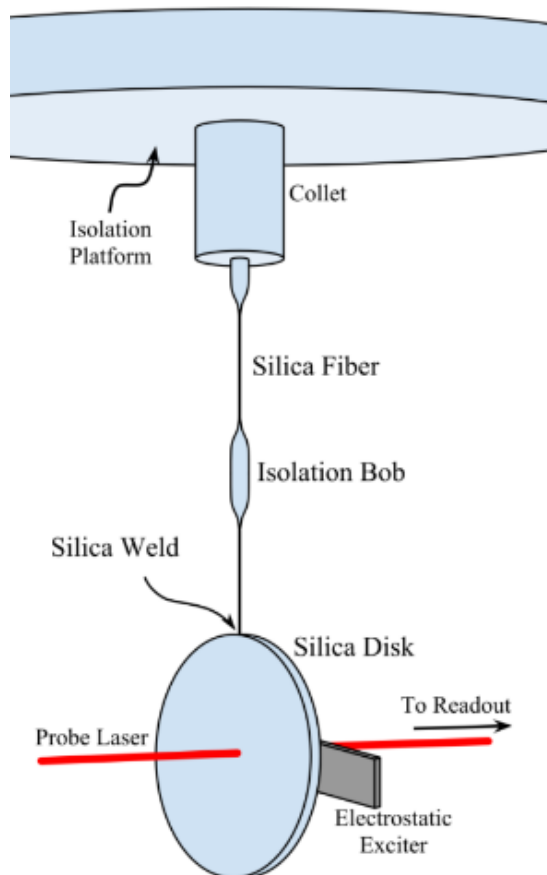
$$C_{12} = 55.9 \text{ GPa}$$

$$C_{44} = 58.2 \text{ GPa}$$

3 Loss Angles

$$\left. \begin{matrix} \phi_{11} \\ \phi_{12} \end{matrix} \right\} \text{ Bulk}$$

$$\phi_{44} \text{ Shear}$$



Mechanical Ringdown

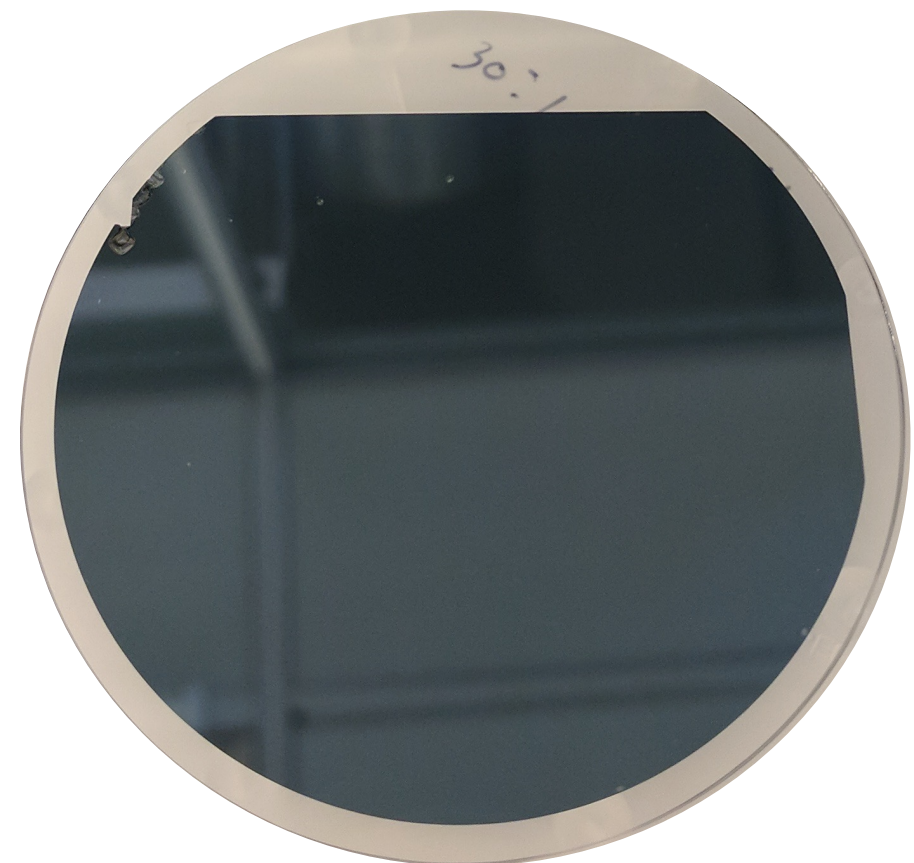
75 mm x 1 mm FS disks

$$\phi_{44} < 1 \times 10^{-6}$$

$$\phi_{11} < 2.3 \times 10^{-4}$$

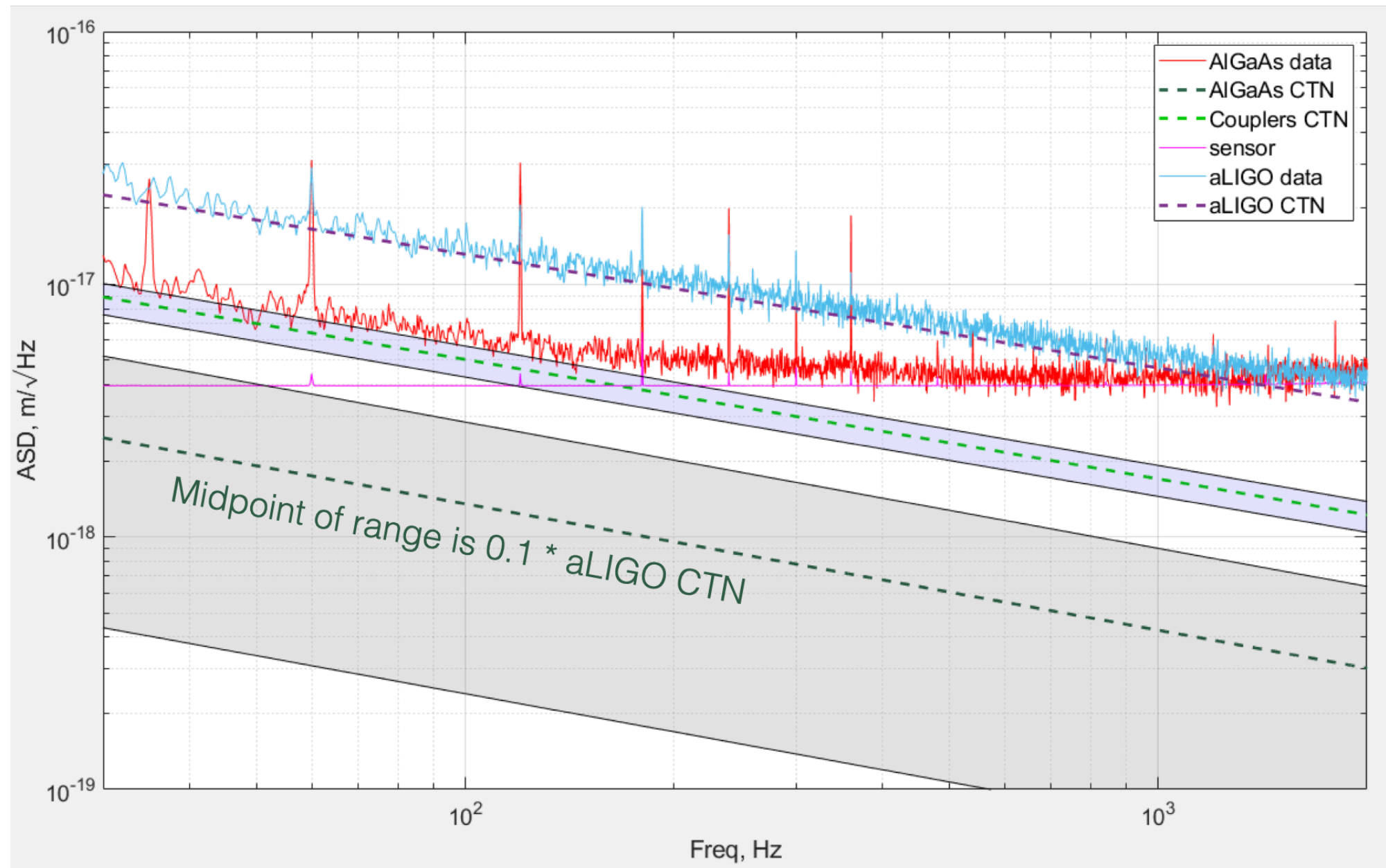
$$\phi_{12} < 5.2 \times 10^{-4}$$

Bulk loss dominated
by thermoelastic loss



Coating Thermal Noise for Crystalline GaAs/AlGaAs

- CTN measured by Nick Demos, Slawek Gras, & Matt Evans @ MIT*
 - Coating layer design optimized by Rana Adhikari to minimize Thermo-optic noise**.
 - Measured noise dominated by cavity end mirrors (couplers)
 - Upper limit for Crystalline mirror CTN is **5x lower than Adv. LIGO**
 - Data mean \Rightarrow Crystalline mirror CTN is **10x lower than Adv. LIGO**
- * LIGO-G2001592
** Coherent Cancellation of Photothermal Noise in AlGaAs Bragg Mirrors, LIGO-P1500054



The Challenges of Crystalline GaAs/AlGaAs Coatings

- Scaling & Cost
- New Locking Scheme
- Birefringence & Noise
- Surface Quality, Uniformity, and Defect Density
- Electro-Optic Noise

Scaling Crystalline Coatings: 30 cm

- **Freiberger Compound Materials:**

- 30 cm GaAs wafers
- 2.6 years: Grow, Cut, Etch, Polish
- 8.2 M€ = \$9.94M
- Selectable orientation: (100) default
- Substrates \approx \$1k each



- **IQE, North Carolina:** MBE coating facility

- \approx 20 Production systems
- 8 hour MBE growth time per coating
- A few weeks to grow all HR coatings
- Growth of 20 cm coatings to test larger profile while 30 cm boule grown
- \$300k/month rent of MBE chamber
- \$3.6 M to grow and process coatings



Bonding Crystalline Coatings: 30 cm

EVG: Bonding the coatings

- Produces robotic bonding machines for the semiconductor industry
- Up to 45 cm bonds
- Promises zero bond defects
- History of high quality, SOI bonds
- Quoted \$4.7M for a 30 cm bonding machine for test mass.
- LIGO must provide polished, cleaned test masses.
- Thorlabs provides coating
- 13 month delivery time

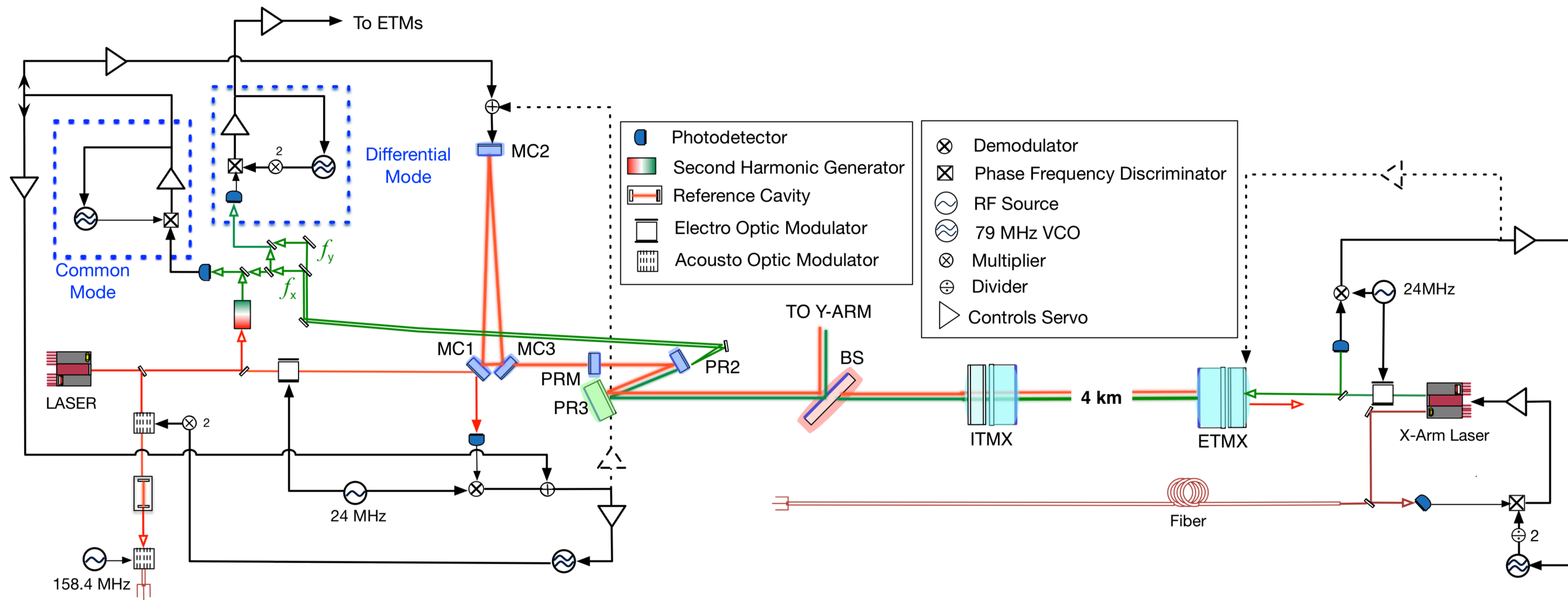


Development: Timeline & Budget

Timeline	Activity	Cost
First Year	<ol style="list-style-type: none">1. Design and order of GaAs crystal wafer (Freiberger)2. Order AlGaAs mirrors for prototype detector (Hannover)3. Continuing noise studies (Syracuse, American, MIT)	\$1.6 M
Second Year	<ol style="list-style-type: none">1. Growth and measurement of gallium arsenide crystal (Freiberger)2. Begin AlGaAs coating bonder construction (EVG)3. Install AlGaAs mirrors in prototype (Hannover)4. Continuing noise studies (Syracuse, American, MIT, Caltech, CSU Fullerton)	\$6.6M
Third Year	<ol style="list-style-type: none">1. Gallium arsenide substrate etching and metrology (Freiberger)2. Bonder delivery (EVG)3. Prototype detector operation (Hannover)4. Continuing noise studies (Syracuse, American, Stanford)	\$5.2M
Fourth Year	<ol style="list-style-type: none">1. Single gallium arsenide wafer deliver (Freiberger)2. AlGaAs epitaxy on GaAs wafer (ThorLabs)3. Continuing noise studies (Syracuse, American, Caltech)	\$4.8M

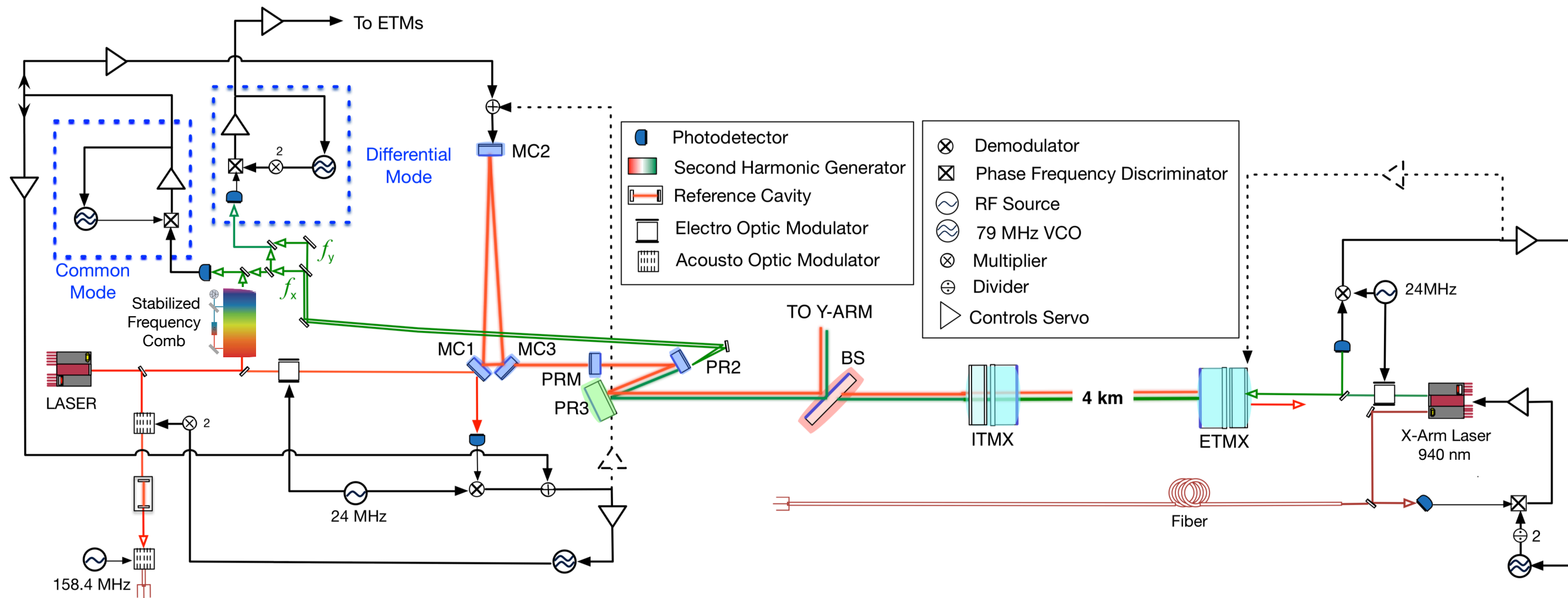
Current Green-Light Arm Length Stabilization System

- Green, frequency-doubled beam (532 nm) is injected through each ETM.
- Each arm separately locked via PDH.
- Differential X-Y transmission signal then adjusted to 0 offset frequency
- Finally ETMs adjusted to lock main beam (1064 nm)



Proposed 940-nm Arm Length Stabilization System

- In each end station, a stabilized Optical Frequency Comb (OFC)^{1,2} is used to phase-lock a 940-nm laser to the main 1064-nm beam, and replaced the 532-nm beam.
- The coatings are manufactured to accommodate a low-finesse 940-nm beam cavity as well as high reflectivity at 1064 nm.
- The transmitted X-Y beams are referenced, via a stabilized OFC, to the main beam
- The locking procedure is otherwise the same.



Graphic adapted from A. Staley LIGO-G1400946

1. T Fortier, E Baumann, "20 years of developments in optical frequency comb technology and applications", <https://doi.org/10.1038/s42005-019-0249-y>

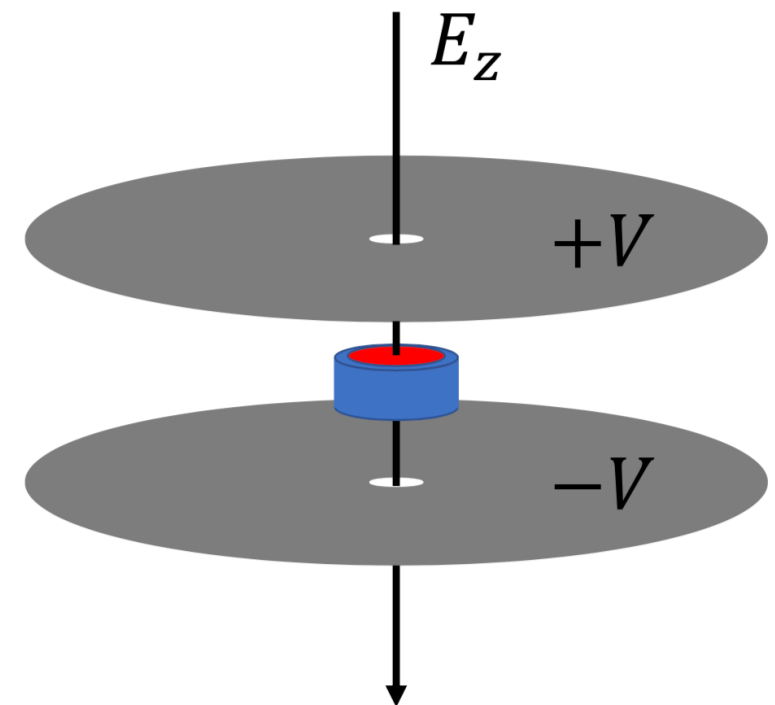
2. Cole, G. D., Zhang, W., Martin, M. J., Ye, J. & Aspelmeyer, M. Tenfold reduction of Brownian noise in high-reflectivity optical coatings. Nature Photonics 7, 644–650 (2013).

Birefringence

- Birefringence arises from differential strain between GaAs/AlGaAs layers.
- $\Delta f \approx 4 - 5$ MHz between polarizations.
- High-Finesse, low-noise cavities, like clock cavities, use a single polarization.
- Investigations by A. & E. Gretarsson (expt) and M. Fejer (theory) to assess possible noise from strain-induced birefringence.
 - Thermally induced strain from beam heating
 - Mechanically induced strain from suspension

Electro-Optic Noise

- Electro-optic noise arises from electric-field-induced changes in index, $\frac{dn(f)}{dE}$
- Thesis experiment by Daniel Vander-Hyde, Syracuse, to measure cavity noise induced by oscillating E-field on cavity mirror.

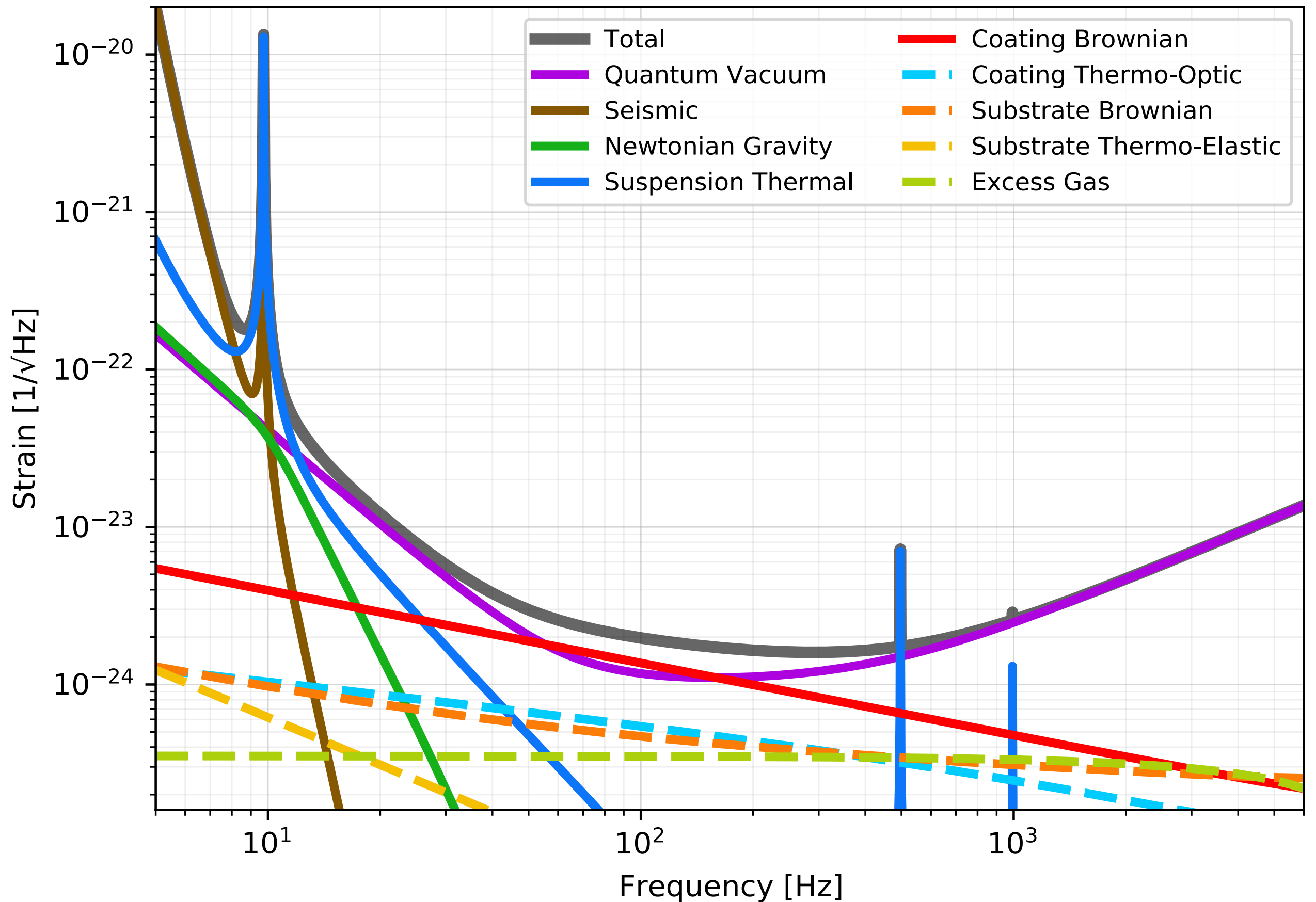


Surface Quality and Uniformity

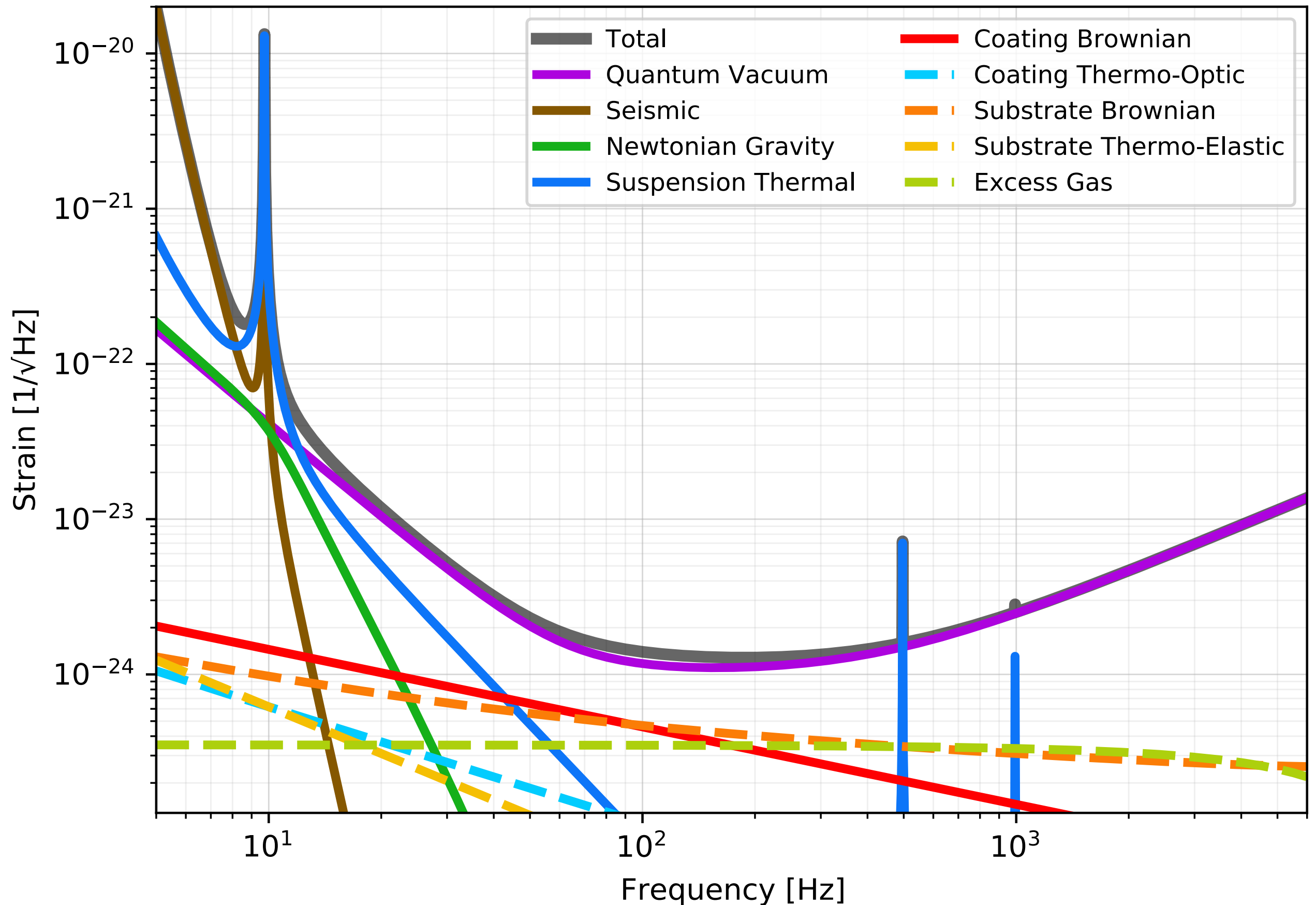
- Crystalline GaAs/AlGaAs coatings currently available up to 20 cm Ø.
- Test to begin this summer on surface quality and uniformity for 10 cm Ø samples.
- Funding sought for tests on 20 cm Ø samples to be completed in the next year.
- Measurements on scatter and absorption at defect sites to follow surface characterization.



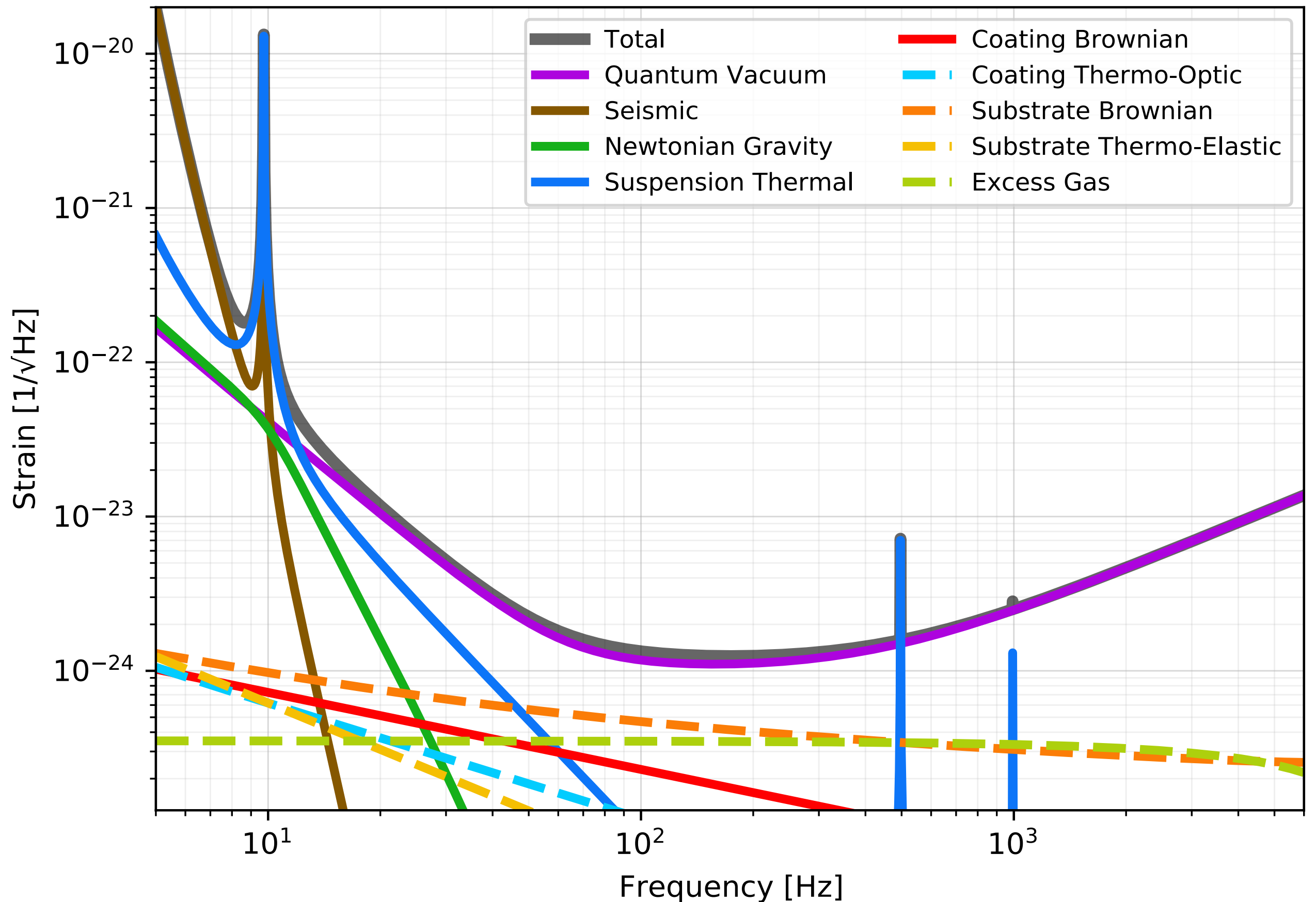
A+ Design Sensitivity



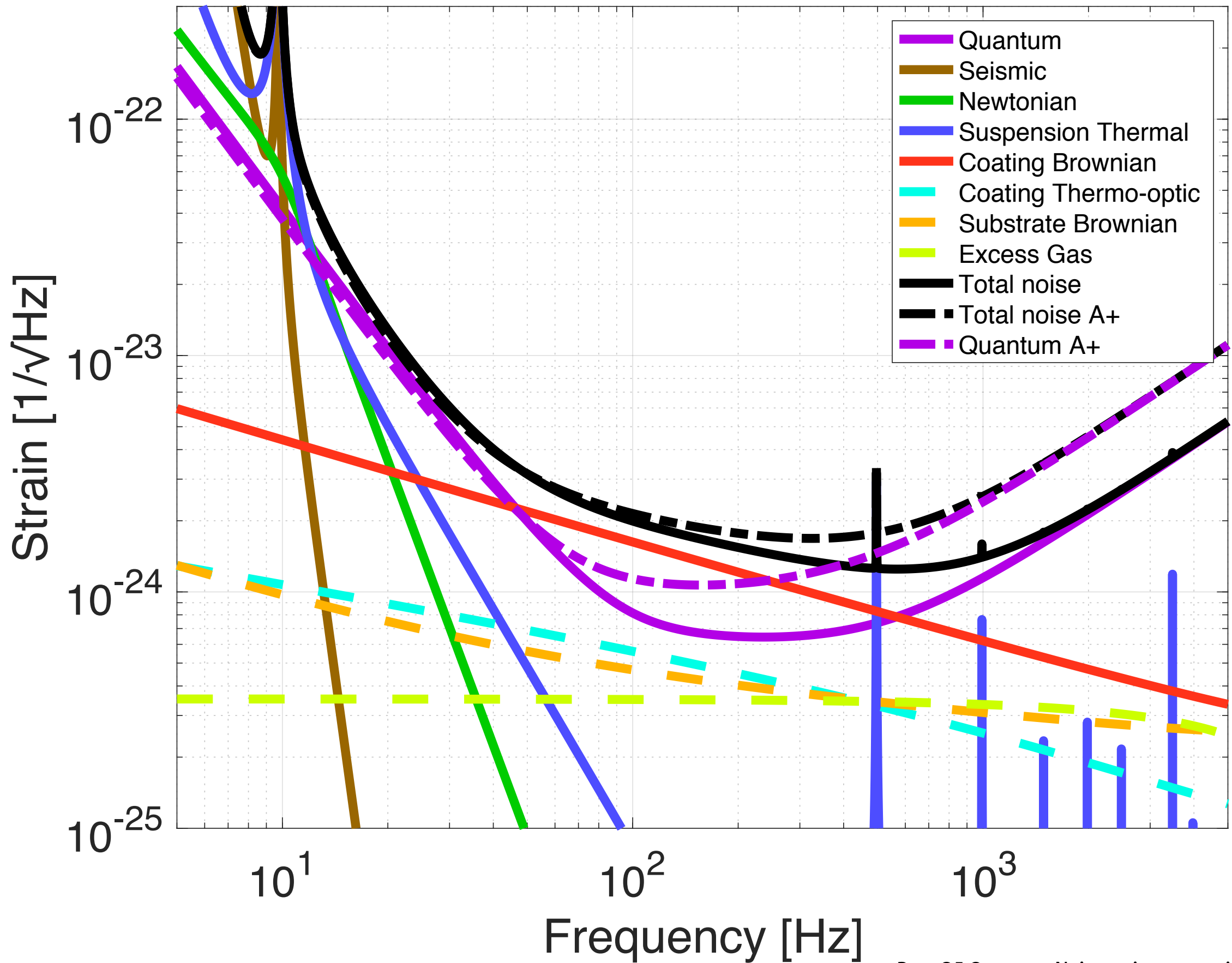
A+ Design Sensitivity + Crystalline Coating (Upper Limit)



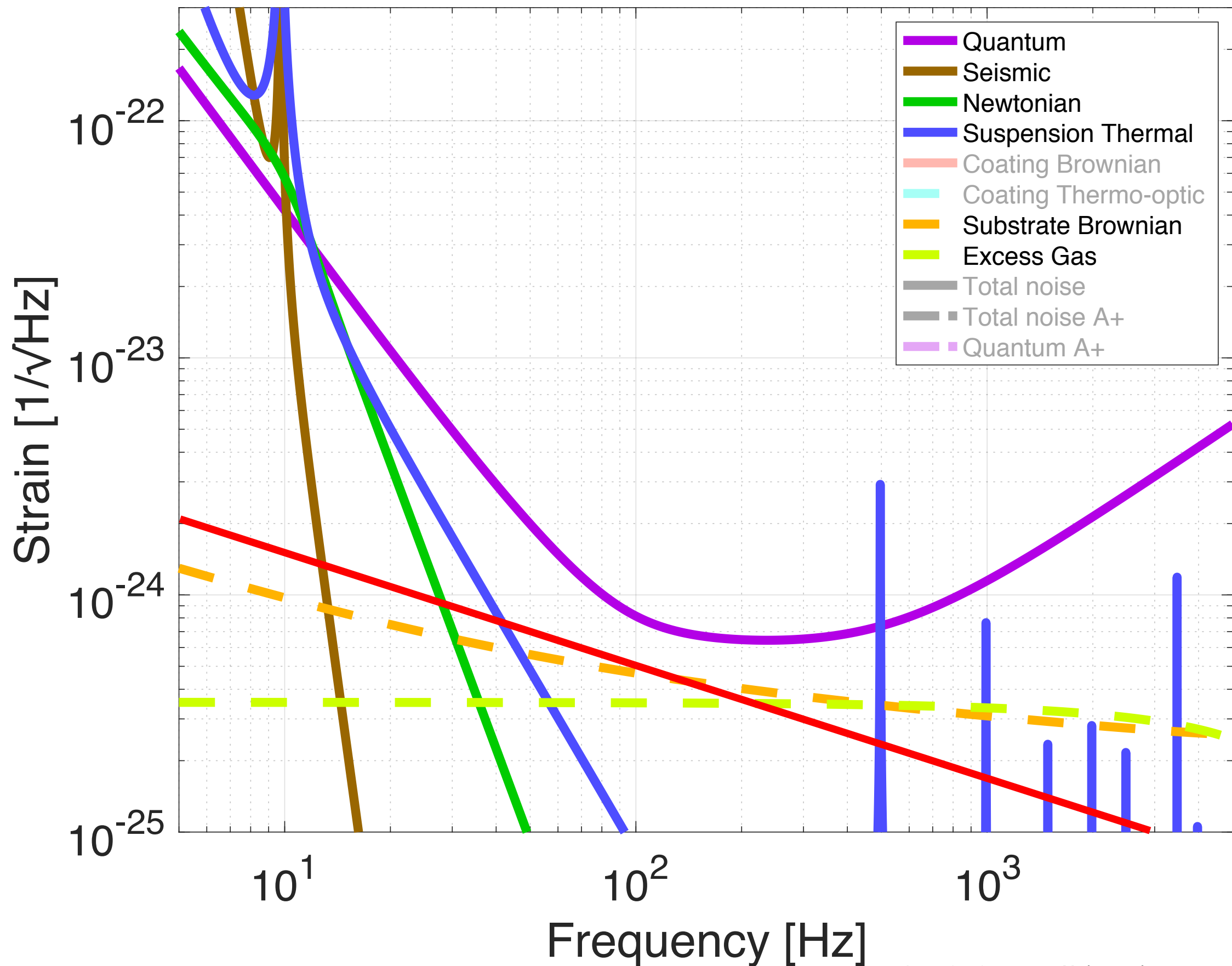
A+ Design Sensitivity + Crystal Coating (Mean Value)



Post-O5 Design: 250 W input, 10dB Squeezing, A+ CTN



Post-O5: 250 W in, 10dB Squeezing, Crystal coatings (upper limit)



Next Steps...

Stage 1:

- Characterize surface quality for 10- & 20-cm coatings
- Raise \$20M for 30-cm development, and
- Continue research on E-O noise, Birefringence noise, ...

Stage 2:

- Retooling and Boule growth for 30-cm wafers,
- With exclusive chamber use, optimize process to minimize absorption, scatter, & defects,
- Order bonding machine
- Continue research on E-O noise, Birefringence noise, ...

Stage 3:

- Grow and bond 30-cm mirrors,
- Test that mirrors meet LIGO spec's, and
- Enjoy a more sensitive detector.

Summary

Thermo-optically optimized,
crystalline GaAs/AlGaAs mirror coatings:

- Extremely low optical losses,
- CTN 5-10x lower than aLIGO coatings, and
- Allows RT Post-O5 upgrade with impressive sensitivity gains.

After 20 years of coatings research ...
Future LIGO need not be limited by CTN.

We need \approx \$22M and a few years to make this reality.